IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MMB Docket No. 1003-0547

LSI Reference: 99-230 Confirmation No.: 4444

Application of: Michael J. Berman Group Art Unit: 2624

Serial No.: 09/553,140 Examiner: Aaron W. Carter

Filed: **April 20, 2000**

For: Determination of Film Thickness During Chemical Mechanical Polishing

I hereby certify that this correspondence is being transmitted via the Electronic Filing System (EFS) to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

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AMENDMENT

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated March 27, 2009, please amend the aboveidentified application as follows:

Amendments to the Claims begin on page 2 of this paper; and

Remarks/Arguments begin on page 9 of this paper.